

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2815

PATENT APPLICATION
Docket No.: 8750-042
Client Ref. No.: SPX200211-0046US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Dae-Woong KANG, et al.

Serial No.: 10/758,802 Examiner: Warren, Matthew E.

Filed: January 15, 2004 Group Art Unit: 2815

Confirmation No.: 6500

For: METHODS OF FABRICATING A SEMICONDUCTOR DEVICE
HAVING MULTI-GATE INSULATION LAYERS AND
SEMICONDUCTOR DEVICES FABRICATED THEREBY

Date: May 24, 2006

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Commissioner for Patents
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AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR 1.116

Responsive to the Final Office Action, Paper No. 20060221, dated February 24, 2006,
please amend the application as follows.

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3
of this paper.

Remarks/Arguments begin on page 7 of this paper.